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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Myung Kwan Ryu et al.)
SERIAL NO: 10/714,226) Group Art Unit: 2813
FILED: November 14, 2003) Examiner: Nguyen, T.T.
TITLE: Method for Fabricating Single Crystal Silicon Film

THE COMMISSIONER FOR PATENTS
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MAIL STOP AMENDMENT

Certification under 37 CFR 1.8a

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to THE COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, Box Mail Stop Amendment, on August 2, 2005

8/2/05
date

M. Pomroy
Maggie Pomroy

AMENDMENT

Sir:

In response to the Office Action dated May 4, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.